

## EAST Search History

| Ref # | Hits | Search Query  | DBs   | Default Operator | Plurals | Time Stamp       |
|-------|------|---|---|------------------|---------|------------------|
| L1    | 2    | (high near voltage near gate near dielectric) and (substrate or wafer) and (tri-gate) and (low near dose near3 nitrogen) and (low near voltage near core near dielectric) and (intermediate near core).clm. | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2006/03/06 18:26 |
| L2    | 2    | (high near voltage near gate near dielectric) and (substrate or wafer) and (tri-gate) and (low near dose near3 nitrogen) and (low near voltage near core near dielectric) and (intermediate near core)      | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR               | ON      | 2006/03/06 18:26 |